

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application: )  
 )  
Hyungsoo Choi ) Before the Examiner  
 ) (Unknown)  
Serial No. New Application )  
 ) Group Art Unit  
Filed April 19, 2004 )  
 )  
ORGANOMETALLIC COMPOUNDS ) Our Ref.: 22010-209  
AND THEIR USE AS PRECURSORS FOR )  
FORMING FILMS AND POWDERS OF )  
METAL OR METAL DERIVATIVES )

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*Edward E. Sowers*  
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Commissioner for Patents  
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Sir:

Pursuant to the duty of disclosure embodied in 37 C.F.R. §1.56, Applicants wish to bring to the attention of the Examiner the references listed on the enclosed Information Disclosure Statement. These references have been cited by the International Searching Authority and have not been previously submitted in this application, nor heretofore cited by the examiner. Copies of the cited references are enclosed in accordance with 37 C.F.R. §1.98.

The filing of this Information Disclosure Statement shall not be construed as an admission that the information cited is, or is considered to be, material to the patentability as defined in §1.56(b).

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Respectfully submitted,

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*(use as many sheets as necessary)*

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Application Number	New Application
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Filing Date	April 19, 2004
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First Named Inventor	Hyungsoo Choi
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Group Art Unit	Unknown
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Examiner Name	Unknown
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Attorney Docket Number	22010-209
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## U.S. PATENT DOCUMENTS

[illegible]

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Application of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>2</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
		GB 717,269	10/27/1954	Azfa Ag Fuer		
				Photofabrikation		
		WO1999KR0000260	12/02/1999	Ahn, et al.		
		JP1996000202661	02/17/1998	Yasuhiro		

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			Application Number	New Application	
			Filing Date	April 19, 2004	
			First Named Inventor	Hyungsoo Choi	
			Group Art Unit	Unknown	
			Examiner Name	Unknown	
Sheet	1	of	2	Attorney Docket Number	22010-209

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s) publisher city and/or country where published	T <sup>2</sup>
		KRUSE, WALTER, ET AL.: "Synthesis and configuration of hydrido(alkyl phosphito)-cobalt and-iron compounds" CHEM. COMMUN., no. 15, 1968, pages 921-922	
		McEWEN, G. K., et al.: "Preparation of hydridonickel phosphites" INORG. CHEM., vol. 13, no. 12, 1974, pages 2800-2802	
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		DATABASE CA 'Online! CHEMICAL ABSTRACTS SERVICE, COLUMBUS, OHIO, US: PARSHALL, G. W.: "Homogeneous catalytic activation of hydrocarbons" retrieved from STN Database accession no. 85:176606 abstract & ORGANOTRANSITION-MET. CHEM., PROC. JPN.-AM. SEMIN., 1ST (1975), MEETING DATE 1974, 127-34. EDITOR(S): ISHII, YOSHIO; TSUTSUI, MINORU. PUBLISHER: PLENUM, NEW YORK, NY	
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		TITUS, D. D., ET AL.: "The Crystal and Molecular Structure of Hydridotetrakis (diethyl phenylphosphonite) cobalt (I)," CHEMICAL COMMUNICATIONS, 1971, pages 322-323	

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Application Number	New Application
Filing Date	April 19, 2004
First Named Inventor	Hyungsoo Choi
Group Art Unit	Unknown
Examiner Name	Unknown
Attorney Docket Number	22010-209

**OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s) publisher city and/or country where published	T <sup>2</sup>
		LANE, P. A. ET AL.: "Metal Organic CVD of Cobalt Thin Films Using Cobalt Tricarbonyl Nitrosyl" CHEM. VAP. DEPOSITION 1998, 4, No. 5, pages 183-186	
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